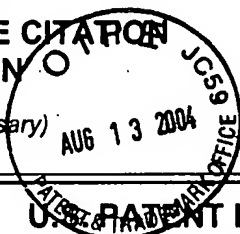


# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Docket Number (Optional)  
81844.0027Application Number  
10/502,062

Applicant

MIKI, et al.

Filing Date

July 20, 2004

Group Art Unit

Not Assigned

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
LB	5,782,740 (corresponding reference Japanese Application No. 10-127790)	07/21/98	SCHNEIDERMAN			
LB	6,533,754 (corresponding reference Japanese Application No. 2001-149482)	03/18/03	HISAMATSU, et al.			

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
LB	2002-045425	02/12/02	JAPAN			Abstract	
LB	61-193670	08/28/86	JAPAN			Abstract	
LB	10-127790 (corresponding reference U.S. Patent No. 5,782,740)	05/19/98	JAPAN			Abstract	
LB	2001-149482 (corresponding reference U.S. Patent No. 6,533,754)	06/05/01	JAPAN			Abstract	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

/Laura Bouchelle/

DATE CONSIDERED

11/02/2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

*(Use several sheets if necessary)*

**Application Number**  
Not assigned

**Group Art Unit**  
Not assigned

[illegible]

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
LB	10-127790	05/19/98	Japan			Abstract	
LB	2001-149482	06/05/01	Japan			Abstract	
LB	2002-045425	02/12/02	Japan			Abstract	

[illegible]

**DATE CONSIDERED** 11/02/2006

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.